



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2818  
Examiner: Chuong A. Luu  
Confirmation No.: 6341

In Re PATENT APPLICATION OF:

Applicant: Noriko Tomita et al. )  
Serial No.: 10/660,490 ) AMENDMENT  
Filed: September 12, 2003 ) in RCE and  
For: SEMICONDUCTOR SUBSTRATE ) PETITION for extension of time  
SURFACE PROTECTION METHOD )  
Attny Ref.: OHG 135 )  
October 10, 2006

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This paper is filed, with an RCE, in response to the Final Official Action mailed on June 15, 2006. Payment for one month's extension of time is attached. Please charge our Deposit Account No. 18-0002 if any additional fees are needed to enter this paper, and please advise us accordingly. It is noted that no petition is required because of the authorization to charge, but this paper is a petition for extension of time. No fee for extra claims is due.

Please consider the Remarks below.

Respectfully submitted,

*Nick Bromer*

Nick Bromer (Reg. No. 33,478)  
(717) 426-1664

RABIN & BERDO, P.C.  
CUSTOMER NO. 23995  
Telephone: (202) 371-8976

October 10, 2006  
Date